## In the Claims:

blackened layer; and

1. (Cancelled) 2. (Cancelled) 3. (Cancelled) (Cancelled) (Cancelled) 6. (Cancelled) 7. (Cancelled) A manufacturing method of an electromagnetic interference (EMI) 8. (Original) shielding filter, the method comprising the steps of: preparing a base film; forming on the base film a first blackened layer and a conductive layer; patterning the first blackened layer and the conductive layer by using a same mask, and

Please cancel claims 1-7 and 10-13 without prejudice.

forming a second, third, and fourth blackened layer for encompassing a front surface and both side surfaces of the conductive pattern.

forming on the rear surface of an EMI shielding layer a conductive pattern comprising the first

	9.	(Origina	al) '	The me	thod	ac	cording	to c	claim	8,	wherein	the	seco	ond,	thire	d an	d fourt	íh
blacke	ned	layers	are	formed	l by	an	electro	less	platir	ng,	screen	prin	ting	or	thin	film	coatin	g
proces	S.																	

- 10. (Cancelled)
- 11. (Cancelled)
- 12. (Cancelled)
- 13. (Cancelled)